

SEP 20 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/671,922
Confirmation No. 8459
Filing Date September 24, 2003
Inventor Garo J. Derderian et al.
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Lynne Ann Gurley
Attorney's Docket No. MI22-2296
Customer No. 021567
Title: Atomic Layer Deposition Methods, and Methods of Forming Materials
Over Semiconductor Substrates

Commissioner for Patents
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2. Statement of the Substance of February 24, 2004 Interview

Dated: 9/20/2007By: 

Natalie King, Legal Assistant
Telephone No. (509) 624-4276
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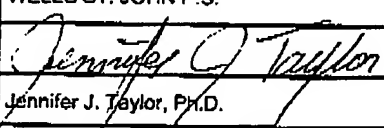
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TRANSMITTAL FORM	Application Number	10/671,922
	Filing Date	September 24, 2003
	First Named Inventor	Garo J. Dardarian et al.
	Art Unit	2812
	Examiner Name	Ahmadi Mohsen
	Attorney Docket Number	MI22-2296
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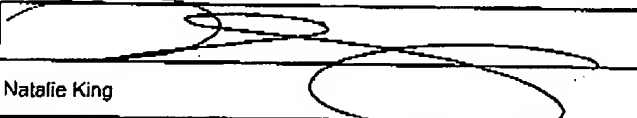
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Remarks _____ Customer No. 021567		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm Name	WELLS ST. JOHN P.S.		
Signature			
Printed name	Jennifer J. Taylor, Ph.D.		
Date	September 20, 2007	Reg. No.	48,711

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Signature			
Typed or printed name	Natalie King	Date	September 20, 2007

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Examiner Ahmadi, Mohsen
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STATEMENT OF THE SUBSTANCE OF AUGUST 9, 2007 INTERVIEW

On 09 August 2007 an interview was conducted by telephone concerning the above referenced application. Participants of the interview were Examiner Mohsen Ahmadi and Jennifer J. Taylor. The interview did not include any exhibits or demonstrations. In response to the Office communication dated 20 August 2007, I, Jennifer J. Taylor, do hereby set forth the substance of such interview.

Claims 35, 37, 38, 39, 40, 41, and 43 were discussed. An agreement was reached to incorporate subject matter from claim 40 and intervening claim 38 into claim 35 and that claim 35 would be allowable over the art of record. Authorization to amend claims 35, 37, 39, 41, and 43 by examiner's amendment was given with cancellation of claim 40 and intervening claim 38.

Respectfully submitted,

Dated:

20 September 2007

By:

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711